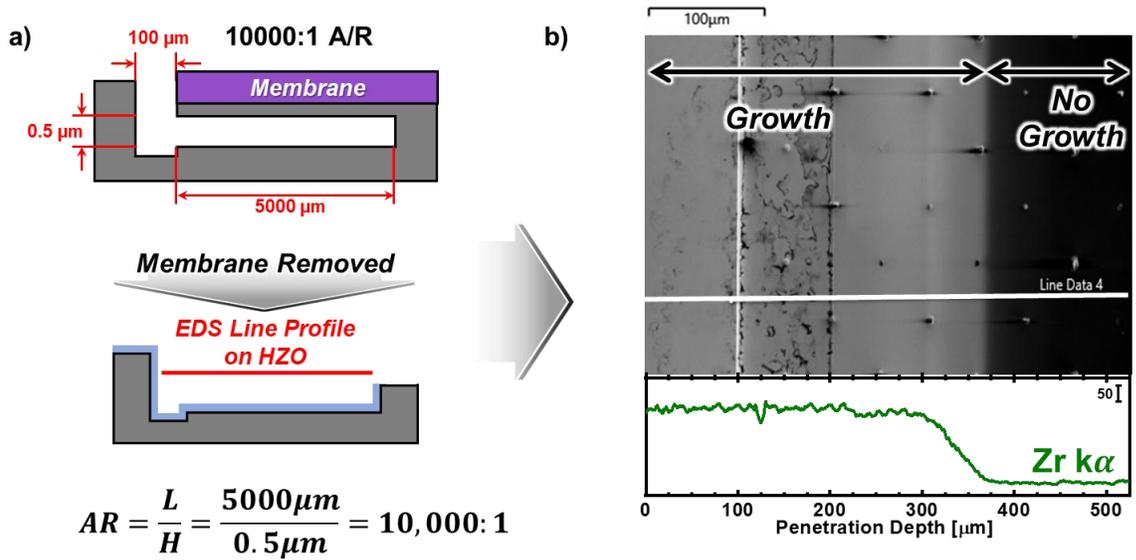
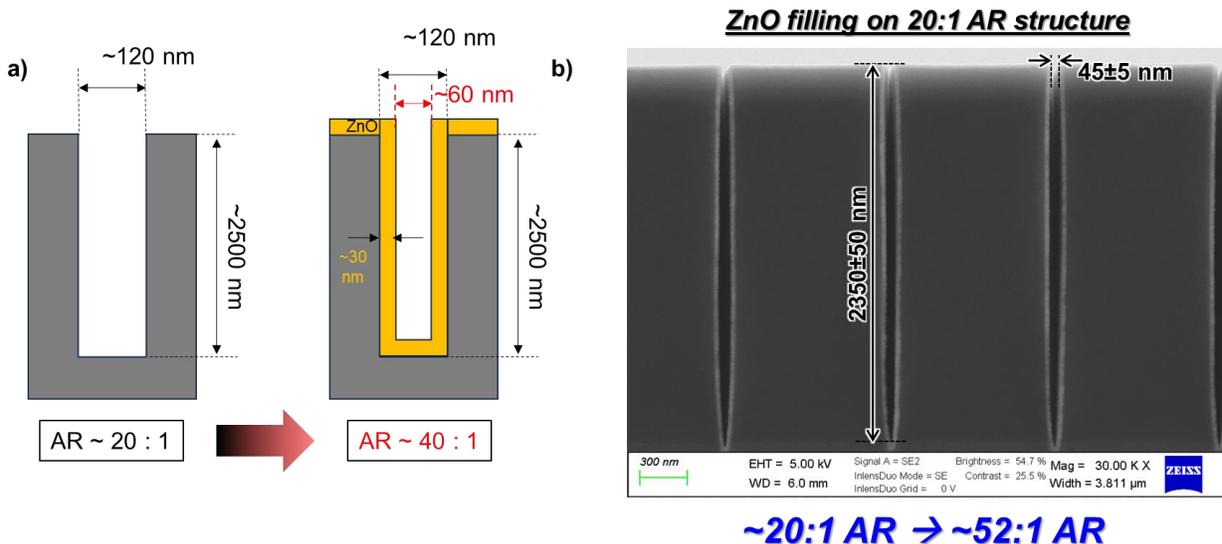


# Title : Impact of Oxidant on Conformal HZO ALD in High Aspect Ratio Structures



**Fig. 1.** (a) Illustration of the lateral U-HAR structure and methodology followed to perform line profile EDS (b) Representative EDS Line profile curves obtained for Zr spectra across HZO growth area on U-HAR structure.



**Fig. 2.** (a) Illustration of vertical trench HAR structure with ZnO decoration used to control aspect ratio. (b) Representative SEM image of HAR trench.